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CONFIRMATION NO. 9323

SERIAL NUMBER 10/750,021	FILING DATE 12/30/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 51876P542
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APPLICANTS

Tae-Woo Jung, Ichon-shi, KOREA, REPUBLIC OF;
 Jun-Hyeub Sun, Ichon-shi, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
 None QVJ

** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 2003-43071 06/30/2003 / QVJ

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 05/04/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Justin J. QVJ</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 15	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
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ADDRESS
 08791
 BLAKELY SOKOLOFF TAYLOR & ZAFMAN
 12400 WILSHIRE BOULEVARD
 SEVENTH FLOOR
 LOS ANGELES , CA
 90025-1030

TITLE
 Method for fabricating semiconductor device having trench type device isolation layer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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